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To cite this article: L X Yang *et al* 2008 *J. Phys.: Conf. Ser.* **121** 022017

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## Pressure induced metallization in ACrO<sub>3</sub> in perovskite compounds

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**Abstract.** We studied the electrical conductivity of ACrO<sub>3</sub> (A=Sr, Ca) perovskites performed at various pressures up to 40 GPa using diamond anvil cell techniques. The samples were synthesized under high pressure high temperature. Pressure induced metallizations were observed in both samples. However the xray diffraction experiments with synchrotron radiation source indicated no discernable crystal structural transition up to 60 GPa. Therefore the pressure induced metallizations were ascribed to electronic type phase transitions. It possibly came from the change of electronic structure due to an orbital ordering evolution induced by pressure.

### 1. Introduction

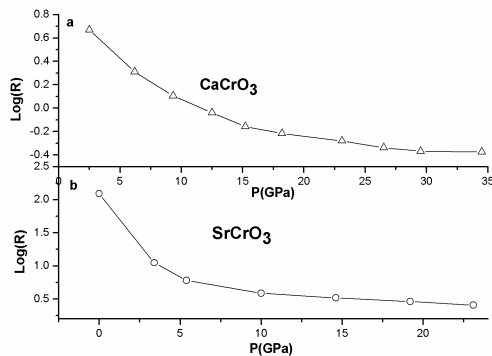
The transition-metal oxides show so many interesting physical properties such as the charge-ordering system La<sub>1-x</sub>Sr<sub>x</sub>FeO<sub>3</sub> [1], La<sub>1-x</sub>Sr<sub>x</sub>NiO<sub>4</sub>[2] and the superconductive system La<sub>2-x</sub>Sr<sub>x</sub>CuO<sub>4</sub> [3] and the metal-insulator transition systems R<sub>1-x</sub>A<sub>x</sub>TiO<sub>3</sub>[4]. The most acceptable explanations of the phenomenon just base the complexity electrical structures and the strong electron-electron interactions [5]. The most of transition-metal oxides with perovskite or a perovskite-related structure is usually very stable under high pressure and the effects of pressure of these materials just are the decrease of the volume and the transition of electrical structures. So the high pressure research of these materials can easily investigate the behavior of the electronic structures. ACrO<sub>3</sub> (A=Ca, Sr) perovskites are Mott solutions with tunable narrow energy gap and replacing Sr by Ca gives an increases the band gap. The x-ray diffraction shows that the crystal structures of Sr/CaCrO<sub>3</sub> keep stable in the pressure range 0-60 GPa at room temperature and the bulk modulus of SrCrO<sub>3</sub> (B<sub>0</sub> =178±5 GPa) is smaller than CaCrO<sub>3</sub>'s (189±2GPa) [6] and it indicates that CaCrO<sub>3</sub> is more difficult to compress under pressure. The bonding instability has been confirmed by the pressure induced bond softening in SrCrO<sub>3</sub> [6]. So ACrO<sub>3</sub> (A=Ca, Sr) is a perfect system to research the behavior of the electrical structures under pressure and we performed the electrical conductivity of ACrO<sub>3</sub> (A=Ca, Sr) performed at various pressures up to 40GPa using diamond anvil cell techniques.

### 2. Experiment

A hardened Be-Cu DAC and a T301 stainless steel were used in our experiments. The pressure medium and the insulator layer is  $\text{Al}_2\text{O}_3$  powder. Pressure was measured by the ruby fluorescence method. The electrical resistance was measured by a real four-probe method. All experiments were performed from 80K to 300K.

### 3. Results and Discussion

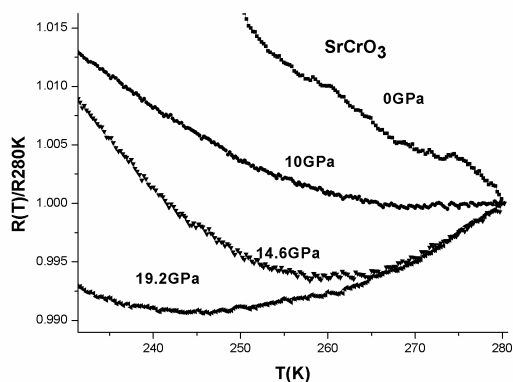
The pressure variation of the electrical resistance  $R(P)$  of  $\text{Sr}/\text{CaCrO}_3$  at a special temperature (280K) is shown in figure. 1.



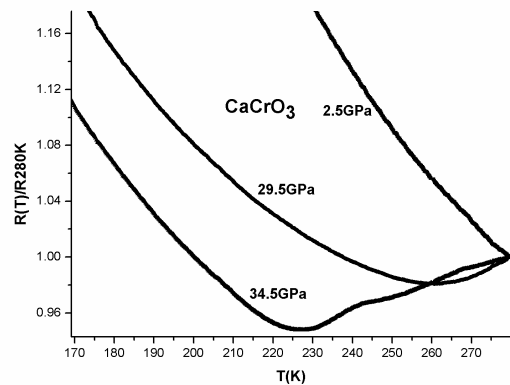
As can be seen a precipitous decrease of  $\text{Sr}/\text{CaCrO}_3$  all occur at low pressure but it mainly come from the decrease of the grain-boundary resistance and the contact resistance under pressure. So the change is not a reliable proof for the insulator to metal transition.

**Figure 1.** The pressure dependence of the electrical resistance of  $\text{Sr}/\text{CaCrO}_3$  under different pressure at 280K.

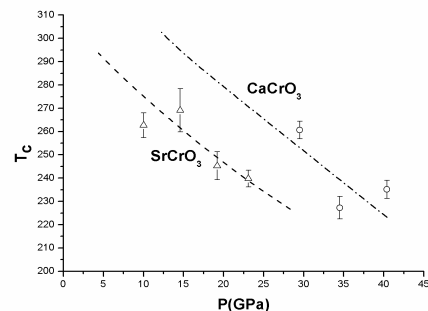
In order to further explore the high pressure electrical state of  $\text{Sr}/\text{CaCrO}_3$  we performed the  $R(T)$  measurement at various pressures. As shown in figure. 2, the  $R(T, 0\text{GPa})$  curve of  $\text{SrCrO}_3$  is typical of



**Figure 2.** The temperature dependence of renormalized resistance of  $\text{SrCrO}_3$ . an insulator and the  $R(T, 10\text{GPa})$  curve with a minimum value at about 260K is a characteristic of the metal-insulator transition (MIT). The temperature of MIT ( $T_c$ ) also decreases under higher pressure and it reaches 240K at the highest pressure 23.1GPa.  $\text{CaCrO}_3$  has the resembled electronic properties under pressure like  $\text{SrCrO}_3$ 's and the start pressure and temperature of MIT is about 29.3GPa and 260.4K (figure. 3). The transition temperature  $T_c$  of  $\text{CaCrO}_3$  also decreases following the increasing of pressure and at the highest pressure 40.4GPa it reaches about 235K. Our results of  $T_c$  of  $\text{SrCrO}_3$  and  $\text{CaCrO}_3$  vs pressure are displayed in figure. 4. We extrapolate the  $T_c(P)$  curves of



**Figure 3.** The temperature dependence of renormalized resistance of  $\text{CaCrO}_3$ .



**Figure 4.** Pressure dependence of the metal-insulator transition temperature of  $\text{Sr}/\text{CaCrO}_3$ .

SrCrO<sub>3</sub> and CaCrO<sub>3</sub> to lower pressure and it would locate the T<sub>c</sub>=290K for SrCuO<sub>3</sub> and CaCrO<sub>3</sub> near 5.5GPa and 16GPa. The transition pressure of CaCrO<sub>3</sub> is much larger than SrCrO<sub>3</sub> and it indicate that CaCrO<sub>3</sub> is more difficult to metallize under pressure.

#### 4. Conclusions

We have performed the electrical conductivity measurements of Sr/CaCrO<sub>3</sub> in DAC. The MIT of Sr/CaCrO<sub>3</sub> under pressure all occur and at room temperature (290K) the transition pressure of SrCrO<sub>3</sub> and CaCrO<sub>3</sub> is 5.5GPa and 16GPa and it belongs to an electronic type phase transition. The MIT of CaCrO<sub>3</sub> the same as SrCrO<sub>3</sub> comes from the pressure induced bond softening and the different band gaps of Sr/CaCrO<sub>3</sub> are the reason of the difference of the metallization pressure. So all the results of Sr/CaCrO<sub>3</sub> indicate that the pressure can change the band gap continuously and these compounds undergo an electronic type phase transition under pressure.

#### Acknowledgements

This work was supported by NSF & MOST through the research projects.

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